

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)	
)	
Fei-Gwo Tsai)	Group Art Unit: 1756
)	
Serial No.: 10/725,810)	Examiner: Young, Christopher G.
)	
Filed: December 2, 2003)	Confirmation No.: 3323
)	
For: Method of Adjustable Matching Map)	TKHR Docket: 252016-2480
System in Lithography)	Top-Team: 0503-7672US
)	

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed August 8, 2006 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.